

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date January 22, 2002

In re the Application of

Masaru MITSUI et al.

Group Art Unit: 1752

Application No.: 09/502,472

Examiner: Y. Clarke

Filed: April 21, 2000

Docket No.: 105875

For: PHOTOMASK BLANK, PHOTOMASK, METHODS OF MANUFACTURING THE SAME  
AND METHOD OF FORMING MICROPATTERN

**LARGE ENTITY PETITION FOR 1<sup>st</sup> - 3<sup>rd</sup> EXTENSION  
OF TIME UNDER 37 C.F.R. §1.136(a) AND  
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Director of the U.S. Patent and Trademark Office  
Washington, D.C. 20231

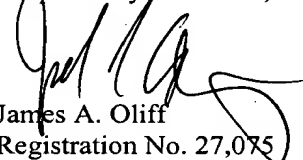
Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired November 22, 2001, an extension of time for a period of 2 months is hereby requested. Attached hereto is our Check No. 127080 in the amount of \$400.00 in payment for:

_____	Extension fee for response within first month pursuant to §1.136(a) (\$110.00)
<u>  X  </u>	Extension fee for response within second month pursuant to §1.136(a) (\$400.00)
_____	Extension fee for response within third month pursuant to §1.136(a) (\$920.00)

The Director is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

  
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